

## Retraction of Nanoembossing Induced Ferroelectric Lithography on PZT Films for Silver Particle Patterning

[*ACS Nano* **2011**, *5*, 6855–6860. DOI: 10.1021/nn202932z].

Zhenkui Shen, Xinping Qu, Yifang Chen,\* and Ran Liu\*

This article was withdrawn at the request of the Editor-in-Chief, with agreement by the authors, due to unacceptable redundant text and figures with a previously published article by the same authors (*Langmuir* **2011**, *27*, 5167–5170. DOI: 10.1021/la200377b).

Published online January 27, 2012  
10.1021/nn2049653